Serial Number: 10/789,042

Filing Date: February 27, 2004

Title: ATOMIC LAYER-DEPOSITED LaAIO3 FILMS FOR GATE DIELECTRICS

CONCLUSION

In accordance with the Notice of Non-Compliant Amendment mailed 12 June 2006, only the non-compliant section of Applicant's previously-submitted Amendment and Response, as identified in the Notice, has been included in this response.

Applicant respectfully requests that the Examiner withdraw the non-compliant status and examine the response as appropriate.

The Examiner is invited to telephone Applicant's attorney at (612) 371-2157 to facilitate prosecution of this application.

If necessary, please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

Respectfully submitted,

KIE Y. AHN ET AL.

By his Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A. P.O. Box 2938
Minneapolis, MN 55402
(612) 371-2157

Date 6 July 200 6

David R. Cochrai Reg. No. 46,632

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop Amendment, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this _____ day of July 2006.

Name

Signature